

RECEIVED
ication Number:
78,150
MAY 8 - 2001
Technology Center 2100
Op Art Unit:

FORM 1449* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)		Docket Number: STL10033/40046.149USU1	Application Number: 09/778,550 <i>MAY 8 - 2001</i> Technology Center 2100
		Applicant: Jonathan W. Haines, et al.	
		Filing Date: February 6, 2001	Group Art Unit: 2100

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DPS Edit Bay, Digital Processing Systems, Inc. pgs. 72-78, 1997



EXAMINER Zhuo Li DATE CONSIDERED August 5, 2003

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.